

## TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

<b>Title of Invention</b>	[METHOD OF FABRICATING SHALLOW TRENCH ISOLATION STRUCTURE FOR REDUCING WAFER SCRATCH]	
<p>Application Number : Date : First Named Applicant: Mr. Jason Lu Confirmation Number: Attorney Docket Number: 13155-US-PA</p>		
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Submitted By:	Elec. Sign.	Sign. Capacity
Dr. Belinda Lee Registered Number: 46863	/Belinda Lee/	Agent

Documents being submitted:	Files
us-assignment	13155-usassn.xml us-assignment.xsl us-assignment.dtd 13155assignment01.tif 13155assignment02.tif
us-request	13155-usrequ.xml us-request.dtd us-request.xsl
us-fee-sheet	13155-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
us-declaration	13155declaration01.tif
application-body	13155-trans.xml us-application-body.xsl application-body.dtd wipo.ent mathml2.dtd mathml2-qname-1.mod isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isogr3.ent isomfrk.ent isomopf.ent isomscr.ent isotech.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isolat1.ent isolat2.ent isonum.ent isopub.ent mmlextra.ent mmlalias.ent soextblk.dtd 13155US0001.tif 13155US0002.tif 13155US0003.tif 13155US0004.tif 13155US0005.tif 13155US0006.tif
us-declaration	13155declaration02.tif
<b>Comments</b>	
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